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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/569,783	02/24/2006	Makoto Tanaka	MESIPO94	6013
58766	7590	03/24/2009		
Beyer Law Group LLP P.O. BOX 1687 Cupertino, CA 95015-1687			EXAMINER MCCALISTER, WILLIAM M	
			ART UNIT 3753	PAPER NUMBER
			MAIL DATE 03/24/2009	DELIVERY MODE PAPER

**Please find below and/or attached an Office communication concerning this application or proceeding.**

The time period for reply, if any, is set in the attached communication.

### Office Action Summary

**Application No.**

10/569,783

**Applicant(s)**

TANAKA ET AL.

**Examiner**

WILLIAM MCCALISTER

**Art Unit**

3753

**Period for Reply** -- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

**Status**

- 1) ☒ Responsive to communication(s) filed on 29 January 2009.
- 2a) ☒ This action is **FINAL**. 2b) ☐ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

**Disposition of Claims**

- 4) ☒ Claim(s) 1-20 is/are pending in the application.
- 4a) Of the above claim(s) 11 is/are withdrawn from consideration.
- 5) ☐ Claim(s) \_\_\_\_\_ is/are allowed.
- 6) ☒ Claim(s) 1-10 and 12-20 is/are rejected.
- 7) ☐ Claim(s) \_\_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

**Application Papers**

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on \_\_\_\_\_ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
- Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

**Priority under 35 U.S.C. § 119**

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some \* c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
  2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
  3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

\* See the attached detailed Office action for a list of the certified copies not received.

**Attachment(s)**

- 1) ☐ Notice of References Cited (PTO-892)
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) ☒ Information Disclosure Statement(s) (PTO-8508)
- Paper No(s)/Mail Date 11/18/08
- 4) ☐ Interview Summary (PTO-413)
- Paper No(s)/Mail Date \_\_\_\_\_
- 5) ☐ Notice of Informal Patent Application
- 6) ☐ Other: \_\_\_\_\_

### **DETAILED ACTION**

Claim 11 was previously withdrawn. Claims 1-10 and 12-20 are pending for immediate consideration.

#### ***Claim Rejections - 35 USC § 102***

1. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.
2. Claims 1-5, 7, 9, 10, 12-17, 19 and 20 are rejected under 35 U.S.C. 102(b) as being anticipated by Ollivier (US 6,450,200).

Regarding claim 1, Ollivier discloses a flow control device (see FIG 1A) for controlling a flow of a fluid in a channel in which the fluid is supplied to a target where a pressure is lower than a fluid supply source, comprising:

- a first opening and closing valve (14) for opening and closing the channel;
  - a flow control component (22) with a flow control valve mechanism for controlling the flow of the fluid flowing through the channel (by virtue of the fact that it's a MFC);
  - a pressure detector (6) capable of detecting a pressure of the fluid on a same side as the flow control valve mechanism relative to the first opening and closing valve;
- and

a deviation measurement/control component (3) for calculating a deviation of the flow controlled by the flow control component from a standard level (from the “specified, desired flow rate”, col. 6 line 6) wherein the deviation measurement/control component:

fixes an aperture of the flow control valve mechanism at a selected aperture opening (which occurs before the first opening and closing valve (14) shuts, see col. 5 lines 54-60), and measures changes in the pressure using the pressure detector *while* the channel is closed by the first opening and closing valve (which occurs after the first opening and closing valve is shut, see col. 5 lines 60-67), and

calculates the deviation from the standard level associated with the selected aperture opening based on the measured changes in the pressure.  
(See response to arguments.)

Regarding claim 2, Ollivier discloses the flow control component (22) to comprise a flow detector capable of measuring the flow of the fluid flowing through the channel on the same side as the flow control valve mechanism relative to the first opening and closing valve (the MFC 22 with an inherent flow sensor is downstream of valve 14), and controlling the flow of the fluid flowing through the channel by adjusting an aperture of the flow control valve mechanism based on a target flow and the flow measured by the flow detector (i.e. - the definition of a MFC with a feedback loop), and

the deviation measurement/control component (3) to be capable of adjusting an output level (the setpoint sent to the MFC) representing the flow by the flow detector

(the MFC's flow detector sets the flow rate, which affects measurement by the pressure sensors) based on the deviation from the standard level (col. 6 lines 1-10).

Regarding claim 3, Ollivier discloses a second opening and closing valve (24) for opening and closing the channel on a side opposite the first opening and closing valve relative to the flow detector. Further, the deviation measurement/control component is capable of reading the output level (of the pressure sensors) representing the flow by the flow detector (the pressure sensors and the MFC's flow detector detect the same flow) while the channel is closed by the first and second opening and closing valves, and adjusting an output level representing zero flow by the detector (just as it does when the second valve is open).

Regarding claim 4, Ollivier discloses an accumulator (5) as claimed.

Regarding claim 5, Ollivier discloses:

a temperature detector capable of measuring a temperature of the fluid on the same side as the flow control valve mechanism relative to the first opening and closing valve (downstream of the on/off valve 14, see col. 5 lines 30-32), wherein

the deviation measurement/control component further calculates the deviation from the standard level (see col. 5 lines 35-47) based on:

an initial pressure  $P_0$  of the fluid at a first time (inherent to  $\Delta P/\Delta t$ ) in a certain time interval ( $\Delta t$ ) including a time the channel is closed by the first opening and closing valve (col. 5 lines 60-63),

an absolute temperature  $T_1$  of the fluid at a second time period in the certain time interval ( $\Delta t$ ), and

a time period from a time the pressure of the fluid reaches a certain first standard pressure  $P_1$ , after the channel is closed by the first opening and closing valve, until a time the pressure reaches a certain second standard pressure  $P_2$  which is different from the first standard pressure  $P_1$  (inherent to  $\Delta P/\Delta t$ ).

Regarding claim 7, Ollivier discloses a mass flow control device comprising a flow control component which has in a channel (1) through which a fluid flows:

a flow detector (inherent to MFC 22) for detecting a mass flow of the fluid that flows through the channel and outputting a flow signal; and

a flow control valve mechanism (inherent to MFC 22) for controlling the mass flow by altering a valve aperture by means of valve drive signals, and controls the flow control valve mechanism based on an externally input flow set signal and the flow signal, wherein a flow control valve mechanism aperture is fixed at a selected aperture opening in response to a selected valve drive signal (before valve 14 is shut, see col. 5 lines 60-67),

the mass flow control device comprises a deviation measurement/control component which has in the channel:

a first opening and closing valve (14) for opening and closing the channel; a accumulator (5) having a certain volume; and

a pressure detector (6) for detecting a pressure of the fluid and outputting a pressure detection signal, and controlling the first opening and closing valve and the accumulator and the pressure detector to perform a mass flow test operations based on the measured pressure changes and a predetermined standard pressure change characteristic associated with the selected aperture opening (col. 5 line 54 to col. 6 line 22).

Regarding claim 9, see the analysis of claim 3.

Regarding claim 10, Ollivier discloses the first opening and closing valve, the accumulator, and the pressure detector to be provided further upstream than the flow detector and the flow control valve mechanism (see FIG 1A).

The method steps of claims 12-17, 19 and 20 would necessarily be performed during the normal and usual operation of Ollivier's device. Regarding claim 19, the verification flow is altered by selection of the aperture opening which occurs in the next iteration of the test procedure (see col. 6 lines 13-22).

***Claim Rejections - 35 USC § 103***

3. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

4. Claims 1-5, 7, 9, 10, 12-17, 19 and 20 are alternatively rejected under 35 U.S.C. 103(a) as being unpatentable over Ollivier in view of Wilmer (US 5,865,205).

Should it be determined that Ollivier does not meet the limitations directed to fixation of the aperture, Wilmer teaches that it was known in the art at the time of invention to fix the aperture of a similar flow control valve (356) after a similar first opening and closing valve (352) is shut (the "initial position" is established, see col. 8 lines 24-32). To avoid initializing the delivery of gas at an undesirable rate, it would have been obvious to one of ordinary skill in the art at the time of invention to initially fix the aperture of Ollivier's flow control valve, as taught by Wilmer.

Also, should it be determined that Ollivier does not inherently disclose a MFC with a set point/measured flow rate comparator, it would have been obvious to one of ordinary skill in the art at the time of invention to use such a MFC to control flow through Ollivier's system. Wilmer teaches that it was known to use such a MFC (308, 360, 370, 332, 357) to control flow through a similar system. The remaining claim recitations read on this combination as they do on Ollivier alone.



Regarding claim 3, Ollivier discloses a second opening and closing valve (24) for opening and closing the channel on a side opposite the first opening and closing valve relative to the flow detector. Further, the deviation measurement/control component (Wilmer's MFC comparator 308) would be capable of reading the output level representing the flow by the flow detector while the channel is closed by the first and second opening and closing valves, and adjusting an output level representing zero flow by the detector.

Regarding claims 4, 5, 9 and 10, see the analyses set forth under paragraph 2 above.

The method claims 12-17, 19 and 20 would necessarily be performed during the normal and usual operation of the Ollivier-Wilmer device.

5. Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ollivier, and alternatively Ollivier and Wilmer, as applied to claim 2 above.

Regarding claim 6, mathematical derivation of an expression from well known physical relationships, and the use of functional equivalents thereof (including the use of a ratio to indicate a difference), was within the skill of an artisan at the time of invention and it would have been obvious to do so with Ollivier's system to achieve similar results.

6. Claim 8 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ollivier, and alternatively over Ollivier and Wilmer, as applied to claim 7, above.

Regarding claim 8, Ollivier discloses the invention as claimed, including that it was known in the art at the time of invention to calibrate a set point based on a result of a test (see col. 6 lines 12-16). Neither Ollivier nor Wilmer teach the step of calibrating the flow detector. However, an MFC's actuation signal was known to be, by definition, a function of the set point and flow rate measurement only. Calibration of a MFC could therefore be performed in a finite number of ways, i.e. - on either of the two inputs, the output, or a combination thereof. Predictably, since only these three signals affect actuation of the MFC, calibration of one rather than the other would have resulted in calibration of the MFC. It therefore would have been obvious to one of ordinary skill in the art at the time of invention to calibrate the flow rate measurement instead of the set point to predictably achieve the same result of MFC calibration.

7. Claim 18 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ollivier, and alternatively over Ollivier and Wilmer, as applied to claim 17, above.

Regarding claim 18, the analysis of claim 8 set forth under paragraph 6 above is incorporated by reference. Normal and usual operation of the resultant device would have necessarily involved the step of calibrating the flow detector automatically based on the test results.

***Response to Arguments***

8. Applicant's arguments filed 1/29/09 have been fully considered but they are not persuasive.

- a. Applicant argues that "the flow control system described in Ollivier specifically teaches away from fixing the aperture of the flow control valve (22) at a selected aperture opening after interruption the flow of gas using valve 14." (Remarks, p. 9, emphasis added.) In response, the claim language does not require fixation of the aperture after shutting the first valve, but only requires the pressure to be measured after shutting the first valve. However, as set forth under paragraph 4 above, Wilmer teaches the limitation as argued.
- b. Applicant argues that "Ollivier also does not teach or suggest calculating 'the deviation from the standard level associated with the selected [fixed] aperture opening based on the measured changes in the pressure.'" (Remarks, p. 9.) In response, Ollivier's measured pressure change is used to calculate an actual flow rate (col. 6 lines 1-5), the actual flow rate is compared to the standard level {i.e. – it is compared to the "specified, standard flow rate", col. 6 lines 5-7}, and the standard level is *associated with* the selected aperture opening because the standard level is used to set the setpoint flow rate of the MFC (col. 6 lines 7-10, 12-16), wherein the setpoint of the MFC determines the aperture opening of the MFC for each iteration.

***Conclusion***

9. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire **THREE MONTHS** from the mailing date of this action. In the event a first reply is filed within **TWO MONTHS** of the mailing date of this final action and the advisory action is not mailed until after the end of the **THREE-MONTH** shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than **SIX MONTHS** from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to **WILLIAM MCCALISTER** whose telephone number is (571)270-1869. The examiner can normally be reached on Monday through Friday, 9-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Huson can be reached on 571-272-4887. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/WILLIAM MCCALISTER/  
Examiner, Art Unit 3753

/Stephen M. Hepperle/  
Primary Examiner, Art Unit 3753

WM  
3/12/2009